

Notice of References Cited

 Application/Control No.
 10/707,453

 Applicant(s)/Patent Under
 Reexamination
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 Examiner
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 2871

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0051819	03-2004	Eom, Sun Kwan	349/032
	B	US-2003/0122771	07-2003	Sumiyoshi et al.	345/102
	C	US-6,857,759	02-2005	Lee et al.	362/225
	D	US-6,707,250	03-2004	Okano et al.	313/582
	E	US-6,683,659	01-2004	Dirscherl et al.	349/32
	F	US-6,678,020	01-2004	Ok et al.	349/61
	G	US-6,420,835	07-2002	Chen et al.	315/169.4
	H	US-4,780,644	10-1988	Sakai et al.	313/582
	I	US-4,772,885	09-1988	Uehara et al.	349/71
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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